

ABSTRACT

The present application provides a manufacturing method for a device which enables manufacture of a device effectively at low cost by dispersingly arranging elements such as TFTs on a final substrate which becomes an active matrix substrate for electro-optic devices, a device obtained by the method, an electro-optic device, and electronic equipment. The method is to prepare a part or all of many elements formed on a first substrate 10 and then these elements are transferred to a second substrate 14. for manufacturing a device. The method has; a first process for forming a separation layer on a first substrate 10; a second process for forming many elements on the separation layer; a third process for adhering the elements to be transferred on the first substrate 10, onto the second substrate 14 via an adhesive layer; a fourth process for exerting a force acting in a direction to separate the first substrate 10 and the second substrate 14, onto the separation layer between the first substrate 10 and the second substrate 14 from one edge of those substrates, and for producing exfoliation in the layer and/or on the interface of the separation layer; and a fifth process for separating the first substrate 10 from which the transfer of elements has been completed, from the second substrate 14.